Notice of References Cited

Application/Control No. Applicant(s)/Patent Under Reexam 10/004,538 Naka et al. Examiner Art Unit Gail Verbitsky 2859 Page 1 of 1

U.S. PATENT DOCUMENTS

	Document Number Country Code-Number-Kind Code	Date MM-YYYY¹	: Name	Classification ²	
Α	6,039,471	3/2000	Wyland	374	43
В	5,881,208	3/1999	Geyling et al.	392	418
С	5,112,136	5/1992	Sakuma et al.	374	44
٥	5,005,985	4/1991	Piokkowska-Galeska et al.	374	44
E	3,733,887	5/1973	Stanley et al.	73	15A
F	3,720,103	3/1973	Adams et al.	73	190H
G	6,183,128	2/2001	Beran et al.	374	44
н	5,297,868	3/1994	Graebner	374	44
1	4,630,938	12/1986	Piorkowska-Palczewska et al.	374	44
J					
к	-				
L					
м					

FOREIGN PATENT DOCUMENTS

	Document Number Country Code-Number-Kind Code	Date MM-YYYY ¹	Country	Name	Classification ²	
N						
0						
Р						
a						
R						
s						
Т						

NON-PATENT DOCUMENTS

Γ		Include, as applicable: Author, Title, Date, Publisher, Edition or Volume, Pertinent Pages
	U	Thin Film Thermal Conductivity Meter, Amer et al. 1997
	v	Assessment of heat Flow through Bulk geologic Material, Green et al. Joint Conferences.1997
	w	Development of NPL Guarded Hot Plate Emissometer, Stacey et al. Joint Conferences. 1997.
	x	

^{*} A copy of this reference is not being furnished with this Office action. See MPEP § 707.05(a). 1 Dates in MM-YYYY format are publication dates.

² Classifications may be U.S. or foreign.